

Effect Adding PVA Polymer on Structural and Optical Properties of TiO₂ Thin Films

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Abstract

Thin films of titanium dioxide TiO₂ pure and TiO₂:PVA polymer were prepared using chemical spray pyrolysis technique on glass substrate preheated at (350 °C) for TiO₂ pure, and at (160 °C) for TiO₂:PVA. with spray rate 3sec./1min, and thickness (250nm). The investigation of (XRD) indicates that structural of TiO₂ pure and TiO₂: PVA thin films they are polycrystalline and XRD investigation is anatase titanium dioxide, intensity of <101> is more than the intensity of <001>, <200> and <105> for TiO₂ and TiO₂:PVA thin films. The optical properties measurement explain the effect of adding PVA on Transmittance, absorptance, refractive index, absorption coefficient and electronic transitions of prepared thin films. and their results observed that filling of PVA caused increase in optical properties generally.

Keywords: titanium dioxide TiO₂, chemical spray pyrolysis, PVA, optical and structural properties, thin films.

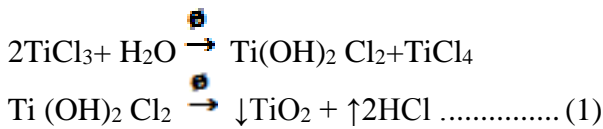
Introduction

Recently conjugated polymers (cps) and inorganic compounds have been intensively investigated for the applications devices as light emitting diodes, photodiodes, sensor smart microelectronic and photovoltaic (cells) [1,2,3]. TiO₂ have the outstanding proportion of high refractive index (N2.5), excellent transmittance in visible as well as high electrical and chemical stability. It has been studied extensively for using in optoelectronic device [4,5] TiO₂ was used as electron accepting material because of its non-toxic and abundance availability to indentify physical and structural properties of semiconductor material, the scope of thin films has enabled this opportunity to study semiconductors through the preparation of films [6], because of easily breaking the thin film which is does not exceed only microns thick it is deposited on certain substrate ,such as glass, silicon ,and alumina^[7]. TiO₂ is found naturally as white material, in three forms of crystalline, Rutile (tetragonal), Anatase (tetragonal), and Brokite (orthorhombic)^[8], TiO₂ films can be prepared by different techniques, such as thermal evaporation in vacuum deposition (TEVD), chemical vapor deposition (CVD), pulse laser deposition (PLD) chemical spray pyrolysis deposition (CSPD) and other method^[9,10,11].

Polyvinyl Alcohol (PVA) is a white and granular, it is soluble in hot water but insoluble in cold water and common organic solvents for many applications^[12], this polymer chose in this research because of its relative ability for preheating (comparing with other polymers) to deposited on glass. Polyvinyl Alcohol is prepared in water solutions on evaporation of water, transparent films are formed which have high tensile strength and tear resistance^[6], PVA polymer has a melting point of 180°C^[13] and it has a molecular weights (26,300, 72,000 and 30,000) g/mol^[14]. The aim of this research is study adding PVA polymer on some structural and optical properties of TiO₂ thin films which prepared by chemical spray pyrolysis technique.

Experimental Work

TiO₂ were prepared by chemical spray pyrolysis technique, which spraying an aqueous solution of titanium chloride TiCl₃, which prepared with (0.1 ml/ mol) by dissolving in distilled water (50 ml) of (H₂O), then the resulting solution was sprayed on clean preheated glass substrate at (350°C). TiO₂ thin films were formed according to equation^[15]:



The resulting films were transparent, white yellowish color, stable free from pin holes and have good adhesive property. Measured by two methods: weight and micro balance. The selected thickness was (250nm).

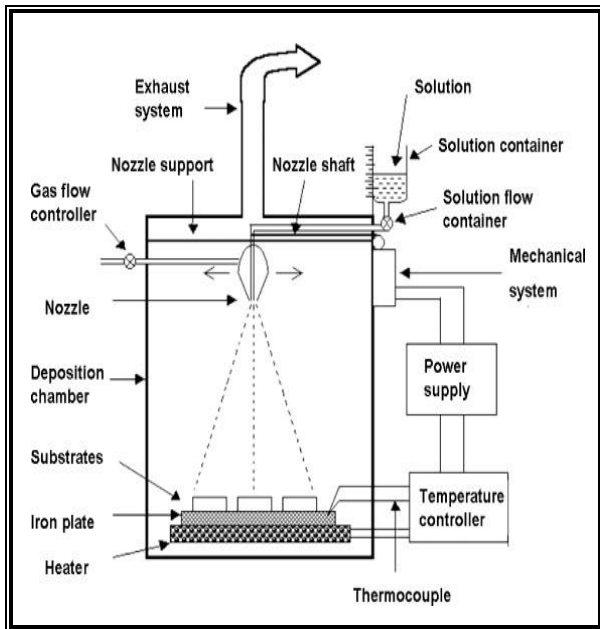


Fig.(1) Equipments of chemical spray pyrolysis system.

To prepare titanium dioxide doped polymer (poly vinyl alcohol) is added (0.065 g) of PVA to the distilled water and they solve exposure solution to heat with constant stirring and after confirmation of soluble polymer is added to the solution titanium chlorides TiCl_3 record advance and then sprayed on the slides glass and degree temperature 160°C producing $\text{TiO}_2:\text{PVA}$ with same thickness (250 nm).

Results and Discussions

A. XRD analysis: The crystalline structure for TiO_2 and $\text{TiO}_2:\text{PVA}$ can be recognized by studying the phase of (XRD) for that material, when a beam of (XRD) from mono wavelength incident on film surface, will exhibit peaks on limit angles for each material because of reflecting of Bragg on parallel crystalline surface. XRD instrument is from type (Shimadzu 6000) made in Japan, with the following specifications are Target is $\text{CuK}\alpha$,

Wavelength is 1.5406 Å, Current is 30 (mA.) and Voltage is (40 KV.). The XRD find that structural of TiO_2 thin film it is polycrystalline and XRD investigation is anatase titanium dioxide, intensity of $\langle 101 \rangle$ is more than the intensity of $\langle 004 \rangle$, $\langle 200 \rangle$ and $\langle 105 \rangle$ which agrees with (ASTM) card, for TiO_2 and $\text{TiO}_2:\text{PVA}$, as shown in Fig.(2).

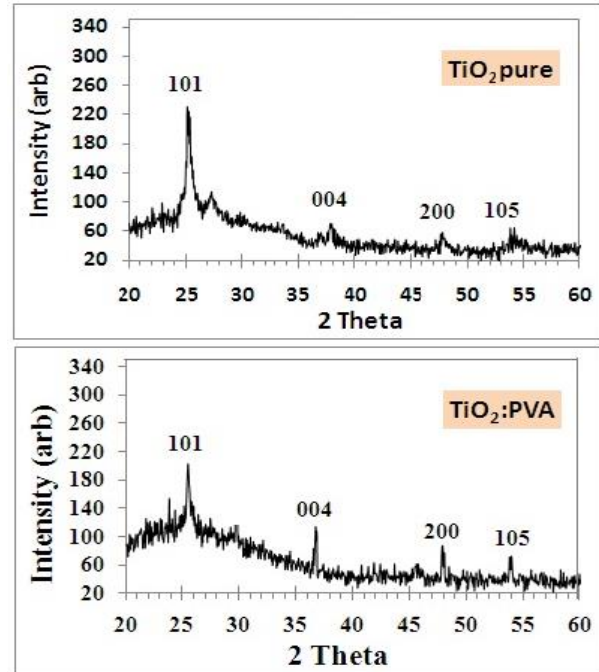


Fig.(2) XRD pattern of TiO_2 pure and $\text{TiO}_2:\text{PVA}$ thin films.

Lattice constants (a) and (c) can calculate from the following equation:

$$\frac{1}{d^2} = \frac{h^2 + k^2}{a^2} + \frac{l^2}{c^2} \dots\dots\dots (2)$$

XRD pattern is observed characteristics diffraction peaks corresponding to the $\langle 101 \rangle$, $\langle 004 \rangle$, $\langle 200 \rangle$ and $\langle 105 \rangle$. The values which measured by XRD instrument of diffraction angle (2θ), interplaner spacing (d) and Full Width at Half Maximum (FWHM) are shown in Table (1) which it emerged adding PVA polymer enhanced the structural properties of TiO_2 thin films that means the degree of crystalline increases because the molecules of TiO_2 come close together.

Table (1)
Some structural properties for TiO₂ pure and TiO₂:PVA thin films.

substrate	hkl	d A°	2θ	FWHM (β)	D _{ave.} A°	a A°	c A°
TiO ₂ pure	101	3.52125	25.2721	0.9233	1.5723	3.7906	9.5107
	004	2.37769	37.8063	0.5917			
	200	1.89835	47.8792	0.7000			
TiO ₂ :PVA	101	3.49702	25.4502	0.1636	8.5829	3.7172	9.9155
	004	2.47889	36.2081	0.1962			
	200	1.87732	48.4497	0.1083			
	105	1.69990	53.8501	0.1150			

B. Optical properties

(1) Transmittance and Absorbance

The transmittance and absorbance of prepared films were measured using (UV-1650PC Shimadzu software 1700 1650, UV-Visible recording Spectrophotometer), (Phillips), Japanese company in the wavelength range (300-850 nm), it is found the transmittance decreasing with add polymer that behavior is vice versa with absorbance behavior as in Fig.(3), which means the PVA polymer enhancement the TiO₂ thin films absorbance, this attributed that when adding PVA to TiO₂ solutions these molecules fills the vacancies between polymer chains.

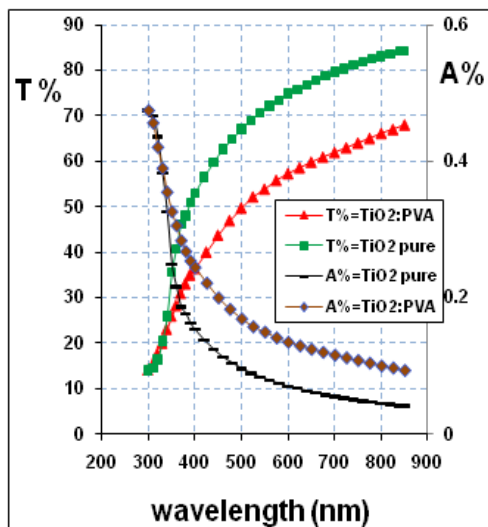


Fig. (3) Transmittance and absorbance of TiO₂ pure, TiO₂:PVA thin films.

(2) Absorption coefficient (α)

The absorption coefficient (α) of thin films prepared was calculated in the fundamental absorption region from the relation [7]:

$$\alpha = 2.303 \frac{A}{t} \dots\dots\dots (3)$$

Where: A : absorbance of the thin film.

t : thickness of thin film, which is 250 nm.

Fig.(4) shows the relation of absorption coefficient as a function of incident photon energy for TiO₂ thin films. The figure shows the high variation. Also we can evidently see that TiO₂ thin films have high value of absorption coefficient (α > 10⁴ cm⁻¹) which leads to increasing the probability of occurrence direct transitions. From the same figure we can notice an increasing in absorption coefficient when we add PVA. This is due to the formation of localized levels near the edge of conduction, that means this decreasing could be attributed to the changes in the particle size distribution function of formed thin films.

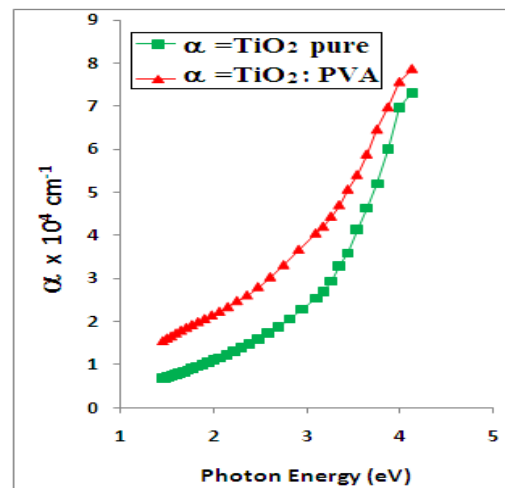


Fig.(4) Absorption coefficient of TiO₂ pure, TiO₂:PVA thin films.

(3) Refractive index (n)

The refractive index (n) of the prepared thin films was calculated according to the following equation [10].

$$n = \frac{1 + \sqrt{R}}{1 - \sqrt{R}} \dots\dots\dots (4)$$

Where R: reflectance of thin film.

Fig.(5) shows the variation of refractive index (n) with photon energy of the prepared thin films. The increase may be attributed to higher packing density and the changes in the particle size distribution function of TiO₂ structural, this the enhancement of growth crystalline this attributed to the molecules of TiO₂ come close together when add PVA polymer[3,6].

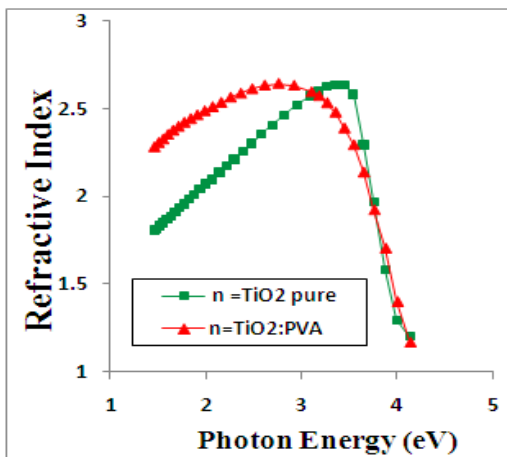


Fig. (5) Refractive Index of TiO₂ pure, TiO₂:PVA thin films.

(4) Energy gap (E_g)

All electronic transitions for the prepared thin films were studied, the direct allowed energy gap in the fundamental absorption region of TiO₂ thin films was calculated from relation: [16]

$$\alpha h\nu = B(h\nu - E_g)^r \dots\dots\dots(5)$$

Where:

hν: photon energy.

E_g: direct allowed energy photon.

B: constant depends on the type of transition.

r: exponential constant, its value depended on type of transition,

r = 1/2 for the allowed direct transition.

r = 3/2 for the forbidden direct transition.

Fig.(6-a) shows the relation of (αhν)² against photon energy, from straight line obtained at high photon energy the direct allowed energy gap could be determined which was equal (3.195eV) at thickness (250nm), and Fig.(6-b) shows direct forbidden energy gap equal (3.052eV). The increase may be attributed to the improvement of growth crystalline that leads to crystallinity of anatase phase^[17].

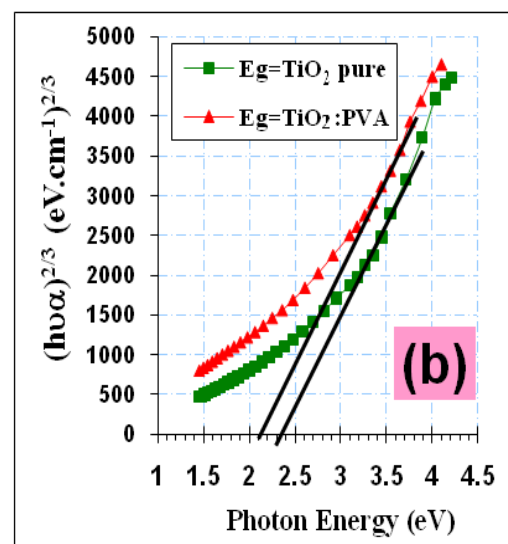
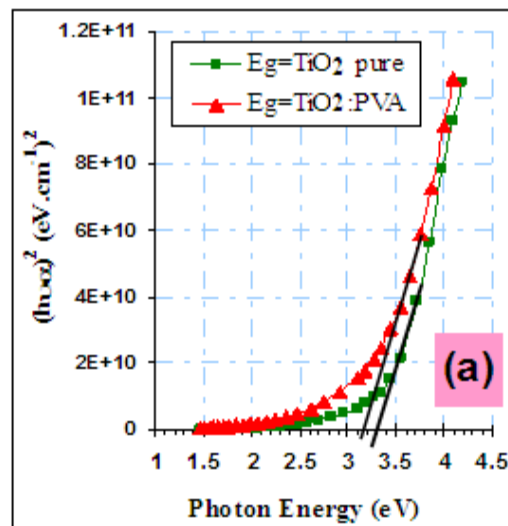


Fig. (6) electronic transitions of TiO₂ pure, TiO₂: PVA thin films. (a) allowed direct transition, (b) forbidden direct transition.

Table (2)
Optical constants of TiO₂ pure, TiO₂:PVA thin films.

Optical Constants	TiO ₂ pure	TiO ₂ :PVA
T%	84.29	67.95
A%	9.02	16.7811
α	73100 cm ⁻¹	78658.69 cm ⁻¹
n _o	2.57	2.64
Allowed Energy Gap E _g	3.352eV	3.195 eV
Forbidden Energy Gap E _g	2.383 eV	2.011 eV

Conclusions

The following major conclusions be drawn from this work on the doped dependence on optical properties and the crystalline structure for TiO₂ and TiO₂: PVA prepared thin films:

1. XRD pattern is observed characteristics diffraction peaks which measured by XRD instrument of diffraction angle (2θ), interplaner spacing (d) and Full Width at Half Maximum (FWHM), PVA enhances the general structural properties of TiO₂ thin films that means PVA increased tie-up of bonds between Ti and O atoms which means the molecules of TiO₂ come close together.
2. Prepared thin films have high values of absorption coefficient for the wavelength range (300-850 nm), It is increased when add PVA polymer.
3. Absorption and refractive index of TiO₂ thin films increase as film doped with PVA.
4. The direct allowed energy gap of TiO₂ and TiO₂ : PVA thin films was (3.195–3.052 eV) respectively, and forbidden energy gap was (2.109–2.383 eV) for TiO₂ and TiO₂ : PVA thin films respectively. This means the PVA decreased the energy gap of TiO₂.

From enhancements for structural results, absorption and electronic transitions for optical properties of TiO₂ thin films prepared, can be using it as benefactor of solar cells after adding PVA polymer.

References

- [1] Jae-Yeol Lee, W.Y.Lee, Duck-Kyun Choi, Jei Oh. "Structure and properties of Co doped TiO₂ thin films on Si (100) by pulsed laser deposition method", "J.Ceramic Processing Res.", Vol.(7), No.(1), pp.(58-61), 2006.
- [2] Doushita K. and Awahara T., "Evaluation of Photocatalytic Activity by Dye Decomposition", "Journal of Sol-Gel Science and Technology", 22, 91–98, 2001.
- [3] Ram A., *Fundamentals of polymer engineering*, Plenum Press, New York, p. 51, 1997.
- [4] Donald. A.N., "Semiconductor Physics and Devices", Irwin, USA, 1992.
- [5] Zhang C., Yuan X., Wu L., Han Y., Sheng J., "Study on morphology of electrospun (poly vinyl alcohol) mats", Eur. Polym. J., 41, pp. 423-432, 2005.
- [6] RADOIČIĆ M., ŠAPONJIĆ Z. V., MARINOVIĆ M. T., CINCOVIĆ, S. P. AHRENKIEL, BIBIĆ N. M. and NEDELJKOVI J. M., "The influence of shaped TiO₂ nanofillers on the thermal properties of poly (vinyl alcohol)", "Journal of Serbian Chemical Society", 76 (0), pp.(1–23), 2011
- [7] Chopra K.L., "Thin films phenomena", Mc.Graw-Hill, NewYork, 1969.
- [8] M.Landmann, E. Rauls and W, G, Schmidt, "The electronic structure and optical response of rutile, anatase and brookite TiO₂," J.Phys.: Condens. Matter, 24, 195503, 2012.
- [9] Chopra K.L., "Thin Film Devices Application", Plenum Press, New York, 1983.
- [10] Eckortova L., "Physics of Thin Films", (plenum press), 1977.
- [11] Hasan M.M., Haseeb A.S.M.A., Saidur R., Masjuki H.H., "Effect of annealing treatment on optical properties of anatase TiO₂ thin films", "International Journal of Chemical and Bimolecular Engineering", Vol.1, pp.93-97, 2008.
- [12] Chide B. T., AL-Wattar A. H., Al-Tememe N. A. A., Twej W. A., Hameed M. A., Ubaid A. Q., Sallman Q. M. and Redha A. B., "Study the Effect of the High Voltage on The preparation of Polyvinyl Alcohol/ TiO₂ Nano Fiber by Electrospinning", "Iraqi Journal of Physics", Vol. 7, No.8, pp. 21- 24, 2009.
- [13] Piorkowska E. and Galeski A. "Thermal conductivity of polymers", International Polymer Science and Technology, Vol.12, No.5. (1985).
- [14] Koski A., Yim K., Shivkumar S.;"Effect of molecular weight on fibrous PVA produced by electrospinning"; Mat. Letter; 58; 493, 2004.
- [15] Areej Adnan Hateef, Batool Daram Balawa, Arwaa Fadil Saleh and Marwa Wailed Mahmmod, "Effect of the thickness on electrical properties of TiO₂ thin films, prepared by thermal chemical spray pyrolysis deposition", "International

Research Journal of Engineering Science, Technology and Innovation (IRJESTI)" Vol.(1), N(6), pp.(175-179), 2012.

- [16] Nilens A.G., "deep imparity in semiconductors", Wiley -Interscience publication, 1973.
- [17] Ristolainen N., Heikkilä P., Harlin A., and Seppälä J., "Electro spun Nanofibers Prepared by two methods: in situ emulsion polymerized PVA/nanoTiO₂ and mixing of functional PVA with nanoTiO₂", "AUTEX Research Journal", Vol. (8), No. (2), 2008.

الخلاصة

حُضرت أغشية ثنائي أوكسيد التيتانيوم الرقيقة النقية TiO₂ و المشوبة بالبوليمر TiO₂:PVA بأستعمال تقنية التحلل الكيميائي الحراري على قواعد زجاجية مسخنة، بدرجة حرارة (350 °C) لتحضير أغشية ثنائي أوكسيد التيتانيوم الرقيقة النقية TiO₂، و بدرجة حرارة ١٦٠ °C لتحضير الاغشية المشوبة بالبوليمر TiO₂:PVA بزمن رش ٣ ثواني لكل دقيقة، و بسُمك ٢٥٠ نانوميتر. فحوصات (XRD) بينت ان التركيب أغشية TiO₂ النقية و المشوبة بالبوليمر TiO₂:PVA بأنها متعددة التبلور polycrystalline نوع anatase و ان شدة <101> أكبر نسبياً من <105> <004>، <200> لكلا الغشائين النقي و المشوب بالبوليمر. كذلك تمت دراسة الخصائص البصرية للأغشية TiO₂ النقية و المشوبة بالبوليمر TiO₂:PVA حيث تم حساب الثوابت البصرية قبل و بعد إضافة البوليمر PVA كالتفافية، الامتصاصية، معامل الانكسار، معامل الامتصاص، الانتقالات الالكترونية المباشرة المسموحة و الممنوعة، حيث بينت النتائج أن إضافة البوليمر PVA أثرت بصورة واضحة في زيادة الثوابت البصرية عموماً لأنه سبب في ربط الاواصر بين الذرات و ذلك ادى الى زيادة الخصائص البصرية و التركيبية أيضاً.